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OF PATENTS AND PUBLICATIONS FOR

APPLICANT'S INFORMATION DISCLOSURE STATEMENT

ATTY. PECKET NO.	SERIAL NO.	
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Yu et al.		
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SAC	Α	4	5	2	3	2	1	1	6/11/85	Morimoto et al.	357	4	3/8/83
1	В	5	4	7	8	6	5	3	12/26/96	Guenzer	428	446	4/4/94
	AA	3	8	0	2	9	6	7	4/9/74	Landany et al.	148	171	8/27/91
	AB	4	4	0	4	2	6	5	9/13/83	Manasevit	428	689	4/7/78
	AC	4	4	8	2	9	0	6	11/13/84	Hovel et al.	357	16	6/30/82
	AD	4	8	4	6	9	2	6	7/11/89	Kay et al.	156	612	9/3/87
	AE	4	8	8	2	3	0	0	11/21/89	Inoue et al.	437	236	10/6/88
	AF	4	8	9	1	0	9	1	1/2/90	Shastry	156	606	6/8/87
· · · · · · · ·	AG	4	9	2	8	1	5	4	5/22/90	Umeno et al.	357	16	3/20/89
	AH	4	9	6	3	9	4	9	10/16/90	Wanlass et al.	357	16	9/30/88
	ΑI	4	9	9	9	8	4	2	3/12/91	Huang et al.	372	45	3/1/89
	AJ	5	1	4	1	8	9	4	8/25/92	Bisaro et al.	437	132	7/20/90
	AK	5	1	5	5	6	5	8	10/13/92	Inam et al.	361	321	3/5/92
	AL	5	1	5	9	4	1	3	10/27/92	Calviello et al.	505	1	12/11/90
	AM	5	2	2	1	3	6	7	6/22/93	Chisholm et al.	148	33	8/3/88
	AN	5	2	2	5	0	3	1	7/6/93	McKee et al.	156	612	4/10/91
	AO	5	2	4	8	5	6	4	9/28/93	Ramesh	428	688	12/9/92
1	AP	5	2	7	0	2	9	8	12/14-93	Ramesh	505	1	8/4/92
	AQ	5	3	1	0	7	0	7	5/10/94	Oishi et al.	501	126	9/28/92
	AR	5	3	2	6	7	2	1	7/5/94	Summerfelt	437	131	5/1/92
	AS	5	4	1	8	3	8	9	5/23/95	Watanabe	257	295	11/9/93
	AT	5	5	5	6	4	6	3	9/17/96	Guenzer	117	90	6/5/95
	AU	5	6	7	0	7	9	8	9/23/97	Schetzina	257	96	3/29/95
	AV	5	6	7	4	3	6	6	10/7/97	Hayashi et al.	204	298.09	6/7/95
	AW	5	7	3	1	2	2	0	3/24/98	Tsu et al.	437	60	6/7/95
	AX	5	7	3	5	9	4	9	4/7/98	Mantl et al.	117	8	4/7/98
	AY	5	7	4	1	7	2	4	4/21/98	Ramdani et al.	437	128	12/27/90
	AZ	5	8	0	1	1	0	5	9/1/98	Yano et al.	438	785	6/14/96
	BA	5	8	1	0	9	2	3	9/22/98	Yano et al.	117	84	5/10/96
	BB	5	8	2	8	0	8	0	10/27/98	Yano et al.	257	43	8/17/95
	BC	5	8	7	4	8	6	0	2/23/99	Brunel et al.	330	285	12/4/96
	BD	6	0	0	2	3	7	5	12/14/99	Corman et al.	343	853	9/2/97
	BE	6	0	4	5	6	2	6	4/4/00	Yano et al.	148	33.4	6/23/98
	BF	6	0	5	5	1	7	9	4/25/00	Koganei et al.	365	158	5/17/99
	BG	6	0	6	4	0	7	8	5/16/00	Northrup et al.	257	96	5/22/98
	вн	6	1	0	3	0	0	8	8/15/00	McKee et al.	117	2	7/30/98
/	BI	6	1	0	7	6	5	3	8/22/00	Fitzgerald	257	191	6/23/98
1/	BJ	6	1	1	3	6	9	0	9/5/00	Yu et al.	117	84	6/8/98
W	BK	6	1	4	3	0	7	2	11/7/00	McKee et al.	117	08	4/6/99

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sæ.	EN	5	9	1	2	0	6	8	6/15/99	Jia	428	210	12/5/96
T	EO	5	8	3	0	2	7	0	11/3/98	McKee et al.	117	106	8/5/96
	EP	5	5	8	8	9	9	5	12/31/96	Sheldon	117	201	5/3/95
	EQ	5	5	1	4	4	8	4	5/7/96	Nashimoto	428	700	10/19/93
	ER	5	4	8	2	0	0	3	1/9/96	McKee et al.	117	108	7/6/93
	ET	5	`4	5	0	8	1	2	9/19/95	McKee et al.	117	84	12/8/93
	EU	5	4	1	8	2	1	6	5/23/95	Fork	505	473	5/15/92
	EV	5	3	9	3	3	5	2	2/28/95	Summerfelt	148	33.3	9/27/93
	EW	5	3	5	8	9	2	5	10/25/94	Neville Connell et al.	505	235	8/10/92
	EX	5	1	7	3	4	7	4	12/22/92	Connell et al.	505	1	3/11/91
1/	EY	4	9	1	2	0	8	7	3/27/90	Aslam et al.	505	1	4/15/88
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	BP	T	0	6	0	7	4	3	5	7/27/94	EPC				X	
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	BR	T	0	5	1	4	0	1	8	11/19/92	EPC				X	
	BT	T	0	9	9	9	6	0	0	5/10/00	EPC				X	
	BU		1	3	1	9	3	1	1	6/6/73	Great Br	ritain			X	
	BV	T	6	2	9	1	2	9	9	10/18/94	Japan				X	
	BW	T	1	1	2	3	8	6	8	8/31/99	Japan				X	
	BX	T	1	1	2	6	0	8	3	9/24/99	Japan				X	
	BY		2	0	0	0	0	3	9	1/5/90	Japan				X	
	BZ		5	0	4	8	0	7	2	2/26/93	Japan				X	
	CA	T	5	2	0	8	8	3	5	7/23/77	Japan				X	
	CB	Τ	5	4	1	3	4	5	5	10/19/79	Japan				X	
	CC	I	5	5	0	8	7	4	2	7/2/80	Japan				X	
	CD		6	1	1	0	8	1	8	5/26/86	Japan				X	
	CE	Ī	6	2	3	2	1	2	6	8/19//94	Japan				X	
	CG		6	3	0	3	4	9	9	2/15/88	Japan				X	
	CI		6	3	1	3	1	1	0	6/3/88	Japan				X	
	СН		6	3	1	9	8	3	6	8/17/88	Japan				X	
	CK		6	3	3	4	1	6	8	6/14/93	Japan				X	
	CK		9	9	1	4	8	0	4	3/25/99	PCT				X	
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	CM	"GaInAs Superconducting FET," IBM Technical Bulletin, vol. 36, no. 8, Aug. 1993, p. 655.
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	СР	"Roles of Buffer Layers in Epitaxial Growth of SrTiO ₃ Films on Silicon Substrates," Moon et al., Japan J of Appl Phys., vol. 33, 1994. pp 1472-1477.
	CQ	"GaAs Heteroepitaxial Growth on Si Substrates with Thin Si Interlayers in Situ Annealed at High Temperatures," Yodo et al., 8257b Journal of Vacuum Science & Technology, 1995, no. 3, pp. 1000-1005.
	CR	"Substrate Effect on the Superconductivity of Yba ₂ Cu ₃ O ₇ Thin Films," Cuomo et al., AIP conference 1988, pp. 141-148.
	CS	"Crystalline Oxides on Silicon: The First Five Monolayers,", McKee et al., Physical Review Letters, vol. 81, no. 14, Oct. 1998, pp. 3014-3017.
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	CU	"Molecular Beam Epitaxy Growth of SrTiO ₃ Films on Si(100)-2 x 1 with SrO Buffer Layer," Tambo et al., Jpn. J. Appl. Phys., vol 37, 1998 pp. 4454-4459.
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7	EA	"Oxide Defined GaAs Vertical-Cavity Surface-Emitting Lasers on Si Substrates," Xiong et al., IEEE Photonics Tech Letters, vol. 12, no. 2, Feb 2000, pp. 110-112.
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